Chapter 4. Properties of optimized compositional 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ solid solution thin films

This chapter includes two sub-chapters. After the optimization process at chapter 4, the properties of the optimized compositional solid solution thin films as a function of their thickness as well as measuring temperature were investigated and discussed. In the section of thickness dependent properties, a possible thin film growth mechanism was discussed. Also, in the section of thermal stability study, the endurance of the solid solution thin films according to the temperature change was studied and compared to other ferroelectric thin films such as Pb(ZrTi)O$_3$ and SrBi$_2$Ta$_2$O$_9$.

4.1. THICKNESS DEPENDENT PROPERTIES OF 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ THIN FILMS

4.1.1 Abstract

The size effect of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin films, prepared by metalorganic deposition technique, were studied by determining how the ferroelectric properties vary with film thickness and grain size. It was found that the ferroelectric properties were determined by the grain size, and not by the thickness of the film in our studied thickness range of 80-350 nm. A 80 nm thick film showed good ferroelectric properties similar to the 350 nm thick film. The possible mechanisms for the size effect in 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ films are discussed.

4.1.2 Introduction

The size effect of ferroelectric bulk materials have been investigated for several decades$^{1,2}$ There has been strong interest in the size effects of ferroelectric thin films in recent year, because of their promising nonvolatile memory applications$^{3-5}$ So far, most studies of the size effects in ferroelectric thin films have focused on ABO$_3$ type materials such as Pb(Zr,Ti)O$_3$, PbTiO$_3$, and BaTiO$_3$. It has been found that the thickness and grain size of the thin film strongly
effect the ferroelectric and optical properties, phase transitions, lattice structure, and stress distribution in ABO$_3$ type materials. Generally speaking, a reduction in film thickness or grain size leads to a decrease in dielectric constant, remanent polarization, dielectric breakdown field, and the tetragonal distortion c/a, and leads to an increase in loss tangent, coercive field, band gap energy, and diffuseness of the phase transitions.

Several mechanisms for size effects in ferroelectric thin films have been postulated based on the effects of electrodes/film interfacial layers, stresses, defects, and domain structure transitions. The following two models may be the most probable mechanisms for size effects. One is the electrodes/film interfacial layers model. The model assumes that an electrodes/film interfacial layers with low dielectric constant is formed at the interface between the electrode and ferroelectric film by the intrinsic stress during the synthesis process of the film. The low dielectric constant interfacial layers results in a decrease in the effective dielectric constant and remanent polarization, and increase in loss tangent and coercive field of the entire film. The other model is based on the domain structure transition from multidomain predominance to single domain predominance at a critical grain size in the film. The lack of the domain walls and the low domain wall mobility in the single domain predominated film, usually associated with small grains, may induce the size effects.

Recently, layered structure ferroelectric thin films, represented by SrBi$_2$Ta$_2$O$_9$, have been intensively studied for their outstanding fatigue free property in nonvolatile memory applications. However, only a little work has been done on the size effects of layered structure ferroelectric thin films. In this article, 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ film was chosen to study the size effects of the film by determining how ferroelectric properties vary with the film thickness and grain size. Our previous articles showed excellent ferroelectric properties for 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ films at a low process temperature of 650 °C, which is about 100 °C lower than usual SrBi$_2$Ta$_2$O$_9$ process temperatures.

### 4.1.3 Experiment

In this study, the 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin films were prepared by our modified metalorganic solution deposition (MOD) technique, using an alkoxide-carboxylate precursor solution. The films were coated on Pt/Ti/SiO$_2$/Si substrates by spin coating. Then the films
were kept on a hot plate (at 350 °C) in air for 10 min. The thickness of each coating layer was controlled by adjusting the viscosity of the solution and the spin speed. This step was repeated after each coating to obtain the desired final film thickness of 50, 80, 100, 280, 350 nm. The films were annealed in a tube furnace at temperature of 650 °C for one hour in an oxygen atmosphere to crystallize the films.

The ferroelectric properties were measured by a RT-66 (Radiant Technology Inc.) test system. The dielectric measurements were also conducted by a HP4192A impedance analyzer. Their microstructure was observed by a D3000 atomic force microscope (AFM) (Digital Instrument, Inc), and a Scintag XDS-2000 x-ray diffractometer (XRD) using Cu $K_{\alpha}$ radiation at 40 kV.

### 4.1.4 Results and Discussion

The films with thickness from 80 to 350 nm showed similar well saturated hysteresis loops, the 50 nm film was electrically shorted. Figure 4-1 shows the hysteresis loop of the film with a thickness of 80 nm. The permanent polarization ($P_r$) of the 80 nm film has 5 µC/cm$^2$ and coercive field ($E_c$) has 63 kV/cm at 2 V and 100 kHz. All the films in the thickness range from 50 to 350 nm showed similar XRD pattern. The XRD pattern indicates that the films were well crystallized. Table 5-1 shows the properties of remanent polarization, coercive field, dielectric constant, and dielectric loss (measured at 100 kHz) as a function of film thickness. The data in Table 4-1 indicates that the electrical properties of the 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ films are independent of film thickness in our studied thickness range. This results are contrary to the reports of piezoelectric (PZT) films, where the electrical properties of PZT films strongly depend on thickness range from 25 to 300 nm.$^{6-8,11,12}$

The films with thickness of 50-350 nm showed similar AFM microstructure. Figure 4-2 shows the AFM microstructure of the 80 nm film. It can be seen in Fig. 4-2 that the film was composed of large stripe shaped grains and small grains. The large stripe shaped grains result in the good ferroelectric properties, and the small grains reduces leakage current to avoid electrical breakdown even in such very thin 80 nm film. A 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ film with a thickness of 350 nm was annealed at 575 °C to obtain grain size of about 50 nm to confirm the
Figure 4-1. Hysteresis loop of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ film with thickness of 80 nm at 2 V

\[ P_r = 5 \, \mu\text{C/cm}^2 \]
\[ V_c = 0.5 \, \text{V} \]
Table 4-1. Electrical properties of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin films with different thickness

<table>
<thead>
<tr>
<th>Film thickness (nm)</th>
<th>$P_r^a$ ($\mu$C/cm$^2$)</th>
<th>$E_c^a$ (kV/cm)</th>
<th>Dielectric constant</th>
<th>Dielectric loss</th>
</tr>
</thead>
<tbody>
<tr>
<td>80</td>
<td>5</td>
<td>63</td>
<td>145</td>
<td>0.022</td>
</tr>
<tr>
<td>100</td>
<td>5.6</td>
<td>65</td>
<td>150</td>
<td>0.023</td>
</tr>
<tr>
<td>280</td>
<td>5.8</td>
<td>70</td>
<td>152</td>
<td>0.025</td>
</tr>
<tr>
<td>350</td>
<td>5.5</td>
<td>71</td>
<td>149</td>
<td>0.024</td>
</tr>
</tbody>
</table>

$^a$ At an applied field of 250 kV/cm
Figure 4-2. The AFM pictures of $0.7$SrBi$_2$Ta$_2$O$_9$-$0.3$Bi$_3$TaTiO$_9$ film with thickness of 80 nm
role of the grain size in the size effect of the ferroelectric thin films. No ferroelectric properties were obtained in this film. It may be concluded that the grain size rather than the film thickness is the main factor for the size effects in these layered structure 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ films.

As we know, the ferroelectric properties are determined mainly by the ferroelectric domain structure, domain nucleation, and the domain mobility. In transmission electron microscopy (TEM) observation of PbTiO$_3$ film, Ren et al.\textsuperscript{19} found that domain structures and domain wall mobility were related to the grain size. The domain structure transition from multidomained predominance to single-domain predominance in PbTiO$_3$ films occurs when the grain size was below a critical grain size. The single-domain predominated grain is very stable under an external field, so that domain nucleation very difficult. Therefore, no good ferroelectric properties can be obtained in a single-domain predominated film, which usually has small grain. A similar dependence of ferroelectric properties on grain size has been found in SrBi$_2$Ta$_2$O$_9$ thin films by M. Nagata and S.B. Desu.\textsuperscript{21} But the difference is that the grain size of SrBi$_2$Ta$_2$O$_9$-based film is mainly determined by process temperature and not by the film thickness. However the grain size of ABO$_3$ materials is controlled not only by process temperature but also by the film thickness.

Several researchers have reported a linear relationship between the grain size and the film thickness from 25 to 300 nm in ABO$_3$ type ferroelectric films, such as Pb(Zr,Ti)O$_3$ \textsuperscript{6,8} and PbTiO$_3$ \textsuperscript{11}, but this relationship was not observed in layered SrBi$_2$Ta$_2$O$_9$-based thin films. We think that a small tetragonal distortion in ABO$_3$ type ferroelectric films makes the formation of spherically shaped grains much easier, and causes the grain size to be limited by the film thickness. However, the large difference between interatomic distance of $a$ and $c$ axis in the layered structure thin film causes anisotropic grain growth. Anisotropic grain growth is not limited by the film thickness, and causes the stripe shaped grains (as seen in this article).

4.1.5 Conclusion

A series of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin films with thickness from 50 to 350 nm were fabricated by the MOD method. The size effect of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin films have been studied by comparing ferroelectric properties with film thickness and grain size. It has
been found that the ferroelectric properties were determined by the grain size, and not by the thickness of the film in our studied thickness range of 50-350 nm. In contrast with ABO$_3$ type materials, the grain size is independent of the film thickness in layered ferroelectric materials. A 80 nm thick 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_2$TaTiO$_9$ film showed good ferroelectric properties similar to the 350 nm thick film. We believe that the large difference between the interatomic distance of a and c in the layered ferroelectric materials causes anisotropic grain growth. Anisotropic grain growth results in grain size that is not limited by the film thickness.

4.1.6 References

4.2 THERMAL STABILITY OF FERROELECTRIC 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ SOLID SOLUTION THIN FILM

4.2.1 Abstract

We have investigated the ferroelectric properties for 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ solid solution thin films as a function of temperature. A solid solution of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin film was prepared by means of metalorganic deposition method onto platinized silicon. We found that this film shows a stable polarization hysteresis loop at temperatures as high as 200 °C, which is higher than that of Pb(Zr,Ti)O$_3$ thin film, as well as of SrBi$_2$Ta$_2$O$_9$. The observed remanent polarization ($2P_r$) at 170 °C was 23 µC/cm$^2$ and showed only a 10 % reduction from its room temperature value. Such thermal stability is believed to be due to lower Schottky barrier height of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ (0.17 eV) as compared to that of Pb(Zr,Ti)O$_3$ (0.45 eV), assuming that the leakage current of these films are dominated by Schottky emission. A higher Curie temperature of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ (450 °C) than that of SrBi$_2$Ta$_2$O$_9$ (310 °C) may be also responsible for the thermal stability of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$.

4.2.2 Introduction

Ferroelectric thin films have been intensively studied over the past few years as candidates for specific microelectronic applications including electrooptic sensors, electromechanical actuators and nonvolatile ferroelectric random access memories (NvFRAMs). Amongst them, Pb(Zr,Ti)O$_3$ and SrBi$_2$Ta$_2$O$_9$ thin films are the promising NvFRAM materials, for their synthesis and processing techniques as well as electrical characteristics are appreciably established and well understood. Despite their notable ferroelectric properties, the Pb(Zr,Ti)O$_3$ thin films with conventional Pt electrodes have a serious problem of polarization fatigue and SrBi$_2$Ta$_2$O$_9$ has a demerit of high processing temperature around 750 °C. Desu et al have reported that a solid solution of SrBi$_2$Ta$_2$O$_9$, such as (1-x)SrBi$_2$Ta$_2$O$_9$-xBi$_3$TiNb and (1-x)SrBi$_2$Ta$_2$O$_9$-xBi$_3$TaTiO$_9$ showed decent ferroelectric properties at a processing temperature as low as 650 °C. In the end, it has been shown that the most suitable ferroelectric properties for the NvFRAM application were obtained at the composition of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$.  

75
One of the important properties of NvFRAMs is the stability at high temperatures for the reliable operation of the device as well as for the specific applications which require endurance in the presence of thermal shock. The thermal stability of Pb(Zr,Ti)O$_3$ thin film capacitors in 64 kbyte NvFRAMs up to 125 °C was reported by Yoo et al. in that, Pb(Zr,Ti)O$_3$ thin films showed pyroelectric effect that may cause the device malfunctioning. Also temperature dependent ferroelectric behavior of SrBi$_2$Ta$_2$O$_9$ thin film capacitor was reported by Taylor et al., where large amount of polarization reduction was observed at temperatures higher than 150 °C. In this chapter, we present the thermal stability of the 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin film capacitor, as compared to that of SrBi$_2$Ta$_2$O$_9$, as well as of Pb(Zr,Ti)O$_3$.

4.2.3 Experimental Procedure

Pb(Zr,Ti)O$_3$ thin films with the composition of Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$ were prepared by the conventional sol-gel method and the modified metalorganic synthesis method was adopted for the preparation of SrBi$_2$Ta$_2$O$_9$ and 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin films. To obtain proper ferroelectric properties, 5% of excess bismuth was added to the stoichiometric SrBi$_2$Ta$_2$O$_9$ composition. The resultant thickness of the films was determined by means of spectroscopic ellisometry. The measured Pb(Zr,Ti)O$_3$ layer was approximately 230 nm, and 290 nm for the SrBi$_2$Ta$_2$O$_9$ and 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin films. Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$ films were annealed at 600 °C for one hour and an annealing temperature of 750 °C was used for SrBi$_2$Ta$_2$O$_9$ and 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$. The Pt top electrodes of 140 nm in thickness and 3.5×10$^{-4}$ cm$^{-2}$ in area were sputter-deposited using a shadow mask for all the films, and the films were annealed at 600 °C for 5 min prior to the electrical measurements. The ferroelectric properties were measured by using a RT66A standard ferroelectric tester (Radiant Technologies). Dielectric constant and loss factor were measured by using a LF impedance analyzer (HP 4192A) at 100 kHz at the oscillating level of 10 mV. The measurement of leakage current-voltage (I-V) characteristics was carried out by using a electrometer/source (Keithley 617). The bias voltage, starting from 7 volt, was applied to the grounded bottom electrode with step mode of both delay time and interval time of 60 s and step voltage of -0.2 volt, which could measure only non-switching polarization current excluding any additional poling process in the leakage current measurement. Details of this methods will be described elsewhere.
4.2.4 Results and Discussion

The temperature dependence of the P-E hysteresis behavior was performed using a 3 inch diameter thermal chuck inside a shielding box to preserve constant temperature. A 20 min delay time was applied prior to each electrical measurement to stabilize the temperature. Figure 4-3 (a)-(c) shows typical temperature dependent P-E hysteresis loops for 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$, SrBi$_2$Ta$_2$O$_9$, and Pb$_{1.1}$Zr$_{0.53}$Ti$_{0.47}$O$_3$ thin film capacitors, respectively. As seen in Fig. 4-3 (a), thermal P-E hysteresis behavior of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ is more stable than that of the others. There was no observable decrease of remanent polarization at 170 °C. In the case of SrBi$_2$Ta$_2$O$_9$, as shown in Fig. 4-3 (b), remanent polarization at the temperature of 170 °C almost vanishes. On the other hand, the Pb$_{1.1}$Zr$_{0.53}$Ti$_{0.47}$O$_3$ thin film showed quite different thermal behavior of the P-E loop different from that of bismuth layered structure materials, as shown in Fig. 4-3 (c). The P-E loops of Pb$_{1.1}$Zr$_{0.53}$Ti$_{0.47}$O$_3$ at temperatures of 140 °C showed distorted loop, which is caused by leakage current through the Pb$_{1.1}$Zr$_{0.53}$Ti$_{0.47}$O$_3$ body at 140 °C. However, like in the case of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$, there was no great change in remanent polarization compared to the value obtained at room temperature.

Figure 4-4 shows that the temperature dependence of the remanent polarization and coercive field of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ and SrBi$_2$Ta$_2$O$_9$ capacitors. As shown in Fig 5-4 (a), reduction rate of 2Pr value in 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin film was slower than the one in SrBi$_2$Ta$_2$O$_9$. Since those two materials have different Curie temperatures ($T_c$) it was expected that the polarization loss of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$, of which has a phase transition temperature is near 450 °C, is smaller than that of SrBi$_2$Ta$_2$O$_9$ when measured at the same temperatures. However, the rate of polarization loss in SrBi$_2$Ta$_2$O$_9$ is quite fast in the temperature range which is still lower than its Curie temperature. As pointed out in the case of PbTiO$_3$, the phase transition temperature of the SrBi$_2$Ta$_2$O$_9$ thin film may be somewhat altered due to the different thermal expansion coefficient of the platinum substrate and the SrBi$_2$Ta$_2$O$_9$ thin film which can cause stress effects on the Curie temperature. In addition, compositional and structural disorder may cause a diffuse phase transition, which was often observed in a ferroelectric relaxor. In fact, the temperature dependent dielectric constant change of the SrBi$_2$Ta$_2$O$_9$ thin film reported by Taylor et al showed quite a rapid increase of the dielectric constant even at near 100 °C. Since 5% of excess bismuth was used to the stoichiometric SrBi$_2$Ta$_2$O$_9$ in this study the
Figure 4-3. Hysteresis loops of (a) 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$, (b) SrBi$_2$Ta$_2$O$_9$ thin films measured at 25 °C and 170 °C, respectively and (c) Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$ thin film measured at 25 °C and 140 °C
Figure 4-4. Temperature dependent (a) $2P_r$ and (b) $2E_c$ of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ and SrBi$_2$Ta$_2$O$_9$ thin films at 5 V
chance of structural disorder in the system is believed to be higher than the stoichiometric 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ thin film. The 2E₉ values at various temperatures are shown in Fig 4-4 (b). The coercive field (2E₉) of the SrBi₂Ta₂O₉ thin film almost disappeared at 200 °C, which indicates the film is close to a linear dielectric material due to a phase transition. Although the 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ has a higher Curie temperature, the reduction rate of the coercive field was not much different from SrBi₂Ta₂O₉. The temperature dependent coercive field change is considered to be not only a function of Curie temperature but also that of the activation energy of domain wall movement. The domains are usually more mobile at a higher temperature, therefore, the coercive field may decrease more rapidly than the change of polarization under a similar temperature range.

The dielectric constant and dissipation factor of the 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ thin film was measured in the temperature range of 25 °C – 300 °C. The increase in dielectric constant, as shown in Fig 4-5, was observed but not as rapid as the one of SrBi₂Ta₂O₉ thin film. The dielectric constant at 300 °C was about 350. The 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ thin film also showed a dielectric loss as small as 0.024 at 300 °C. The small dielectric loss at the elevated temperature may attributed to thermally stable ferroelectric properties of 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ thin film.

Figure 4-6(a) shows the leakage current-voltage (J-V) characteristics of the 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ capacitor in the temperature range of 20-175 °C by applying DC step voltage from 7V to 0.2V. The space charge effect in J-V curves, as reported by K. Watanabe et al., was not observed in this study. The reverse step bias method was applied to eliminate the partial switching polarization current in the course of leakage current measurement of the 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ capacitor as well as that of Pb(Zr,Ti)O₃ and SrBi₂Ta₂O₉. In order to compare the temperature dependent J-V characteristics of 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉ to that of Pb₁.₁(Zr₀.₅₃Ti₀.₄₇)O₃ and SrBi₂Ta₂O₉, we chose the leakage current density at 200 kV/cm in the temperature range of 20-175 °C. Assuming the leakage current density (J) at 200 kV/cm (~5 volts) for all test capacitors is dominated by Schottky emission, a J/T² vs 1/T was plotted as shown in Fig. 5-6(b). Each plot in Fig. 4-6(b) shows a straight line with a slope which is related to the Schottky barrier height. The slopes were 0.17 eV, 0.15 eV and 0.45 eV for 0.7SrBi₂Ta₂O₉-0.3Bi₃TaTiO₉, SrBi₂Ta₂O₉ and Pb₁.₁(Zr₀.₅₃Ti₀.₄₇)O₃, respectively. These values are lower as much as 0.1-0.5 eV than those reported by other groups. Such a difference may
Figure 4-5. Temperature dependence of dielectric constant and loss factor of a 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin film at the frequency of 100 kHz with 10 mV
Figure 4-6. A plot of (a) leakage current density ($J$) vs electric field (kV/cm) for a $0.7\text{SrBi}_2\text{Ta}_2\text{O}_9$-$0.3\text{Bi}_3\text{TaTiO}_9$ thin film with temperature range 15 – 175 °C and (b) $J/T^2$ vs $1/T$ at the electric field of 200 kV/cm for $0.7\text{SrBi}_2\text{Ta}_2\text{O}_9$, $\text{SrBi}_2\text{Ta}_2\text{O}_9$ and $\text{Pb}_{1.1}(\text{Zr}_{0.53}\text{Ti}_{0.47})\text{O}_3$ thin films.
Figure 4-7. Decay in $2P_r$ as a function of number of bipolar switching cycles at the temperature of 170 °C
stems from the different method and the analysis of J-V measurement, which will be discussed in next chapter. From the result of Fig. 4(b), it was observed that the slopes for the 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ and SrBi$_2$Ta$_2$O$_9$ are less steep than Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$, indicating the leakage currents of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ and SrBi$_2$Ta$_2$O$_9$ are thermally insensitive when compared to that of Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$. Hence, as it was seen in Fig. 1(c), the leakage current is a dominant phenomenon which governs the thermal stability of Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$ over the phase transition temperature at 140 °C or above.

The endurance of the 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ capacitor at 170 °C was measured by applying 5 V at 500 kHz. As shown in Fig. 4-7, for the switching cycles of up to $10^8$ there was no significant fall off in $2P_r$. The onset of fatigue is about $1 \times 10^9$ cycles and the $2P_r$ after $10^{10}$ switching cycles is shown to be a 15 % drop from its initial value.

4.2.5 Conclusion

In conclusion, the thermal behavior of ferroelectric 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ solid solution thin films was investigated and compared to other ferroelectric thin film materials such as Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$ and SrBi$_2$Ta$_2$O$_9$. We found that the 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ film showed thermal stability in the polarization hysteresis loop at temperatures up to 200 °C, which is better than that of the Pb(Zr,Ti)O$_3$ thin film as well as of SrBi$_2$Ta$_2$O$_9$. The $2P_r$ and $2E_c$ of the film at 170 °C were 24 µC/cm$^2$ and 83 kV/cm, respectively, with good saturation characteristics. It is seen that both SrBi$_2$Ta$_2$O$_9$ and 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ have lower leakage current than that of Pb$_{1.1}$(Zr$_{0.53}$Ti$_{0.47}$)O$_3$. The higher Curie temperature (450 °C) of 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ may be also responsible for the better thermal stability of the film as compared to SrBi$_2$Ta$_2$O$_9$. 0.7SrBi$_2$Ta$_2$O$_9$-0.3Bi$_3$TaTiO$_9$ thin film has also shown stable polarization up to $10^9$ switching cycles at 170 °C.

4.2.6 References